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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4164**  
Tetsuroh NAKAMURA et al. : Attorney Docket No. 2005\_0724A  
Serial No. 10/533,132 : Group Art Unit 2875  
Filed October 11, 2005 : Examiner Sarah Al-Hashimi

LIGHT SOURCE FOR IMAGE WRITING  
APPARATUS, AND PRODUCTION  
METHOD FOR LIGHT SOURCE

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**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Restriction Requirement of July 21, 2006.

Applicants, by their undersigned representative, hereby elect the invention of Group I which is drawn to a light source for an image writing apparatus by claims 1-10 and 13-16.

Having made the required election, a full examination on the merits of the elected invention is hereby requested.

Respectfully submitted,

Tetsuroh NAKAMURA et al.

By: 

Joseph M. Gorski  
Registration No. 46,500  
Attorney for Applicants

JMG/nka  
Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
August 14, 2006